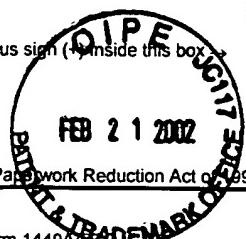


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Application Number	09/900,426				
Filing Date	July 6, 2001				
First Named Inventor	Daiber et al.				
Group Art Unit	2872				
Examiner Name	N/A				
Sheet	1	of	3	Attorney Docket Number	NUFO 002

U.S. PATENT DOCUMENTS

Examiner Initials'	Cite No. ¹	U.S. Patent Documents	Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, columns, lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)		
AU		3,967,211	Itzkan et al.	6/29/76	
		4,309,671	Malyon	1/5/82	
		4,504,950	AuYeung	3/12/85	
		4,560,246	Cotter	12/24/85	
		4,583,227	Kirkby	4/15/86	
		4,770,047	Arditty et al	9/13/88	
		4,839,614	Hill et al.	6/13/89	
		4,843,233	Jeunhomme	6/27/89	
		4,870,269	Jeunhomme	9/26/89	
		4,932,782	Graindorge et al.	6/12/90	
		4,994,677	Graindorge	2/19/91	
		5,028,395	Sebille et al.	7/2/91	
		5,058,124	Cameron et al.	10/15/91	
		5,103,457	Wallace et al.	4/7/92	
		5,115,677	Martin et al.	5/26/92	
		5,141,316	Lefevre et al.	8/25/92	
		5,172,185	Leuchs et al.	12/15/92	
		5,181,078	Lefevre et al.	1/19/93	
		5,185,643	Vry et al.	2/9/93	
		5,225,930	Land et al.	6/6/93	
		5,270,791	Lefevre et al.	12/14/93	
		5,305,330	Rieder et al.	4/19/94	
		5,319,668	Luecke	6/7/94	
		5,321,717	Adachi et al.	6/14/94	
		5,331,651	Becker et al.	7/19/94	
		5,347,527	Favre et al	9/13/94	
UV		5,349,439	Graindorge et al.	9/20/94	
UV		5,349,440	DeGroot	9/20/94	

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PACENTRAL TRADEMARKS

	5,873,515		Wakabayashi et al.	12/13/94	
	5,877,974		Nakatani	2/7/95	
	5,875,474		Reasenberg et al.	5/2/95	
	5,820,687		Kachanov	5/30/95	
	5,828,700		Hall	6/27/95	
	5,438,579		Eda et al.	8/1/95	
	5,450,202		Tisue	9/12/95	
	5,473,625		Hansen et al.	12/5/95	
	5,543,916		Kachanov	8/6/96	
	5,583,638		Cutler	12/10/96	
	5,594,744		Lefevre et al.	1/14/97	
	5,606,439		Wu	2/25/97	
	5,631,736		Thiel et al.	5/20/97	
	5,712,704		Martin et al.	1/27/98	
	5,719,674		Martin et al.	2/17/98	
	5,737,109 --		Goodwin	4/7/98	
	5,760,391		Narendran	6/2/98	
	5,802,085		Lefevre et al.	9/1/98	
	5,825,792		Villeneuve et al.	10/20/98	
	5,886,785		Lefevre et al.	3/23/99	
	5,946,331		Amersfoort et al.	8/31/99	
	5,991,061		Adams et al.	11/23/99	
	6,061,369		Conradi	5/9/00	
	6,084,695		Martin et al.	6/4/00	
	6,108,355		Zorabedian	8/22/00	
	US 6,192,058		Abeles	2/20/01	
	US 6,205,159,		Sesko et al.	3/20/01	
	US 6,246,480		O'Brien	6/12/01	
	US 6,249,364		Martin et al.	6/19/01	
	US 6,252,718		Lefevre	6/26/01	
	US 6,282,215		Zorabedian et al.	8/28/01	
	US 6,304,586		Pease et al.	10/16/01	
	US 6,330,253		Tuganov et al.	12/11/01	
	US 6,331,892		Green	12/18/01	
HJ	USRE 37,044		Wu	2/6/01	

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FOREIGN PATENT DOCUMENTS					
Examiner Initials'	Cite No. ¹	Foreign Patent Documents		Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY
		Office ³	Number ⁴	Kind Code ⁵ (if known)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
HJ		EP	0924628	Kessenich et al.	8/11/1998
HJ		WO	98/44424	Marmor et al.	10/8/1998

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
HU	1	Favre et al.: 'External-Cavity Semiconductor Laser With 15 nm Continuous Tuning Range', Electronics Letters June 19 1986	
FEB 21 2002		Macleod, H. A. in Thin Film Optical Filters 2 nd Edition, McGraw-Hill, 1989, pgs 244-269	
HU	2	Mellis et al.: 'Miniature Packaged External-Cavity Semiconductor Laser With 50Ghz Continuous Electrical Tuning Range' Electronics Letters April 22 1988	
	3	Rosenberg, K. P., et al., "Logarithmically Variable Infrared Etalon Filters," SPIE, Vol. 2262/223, pgs. 223-232	
	4	Scobey M. and Stupik P., "Stable Ultra-Narrow Bandpass Filters," SPIE, Vol. 2262, pgs. 37-46	
HU	5	Siegman A. E., "An Introduction to Lasers and Masers," McGraw-Hill, Inc., 1971	
HU	6	Takashashi, H., "Temperature Stability of Thin-Film Narrow-Bandpass Filters Produced by Ion-Assisted Deposition Applied Optics Vol. 34 No. 4 Feb 1 1995	
	7	Yoder, Optical Instrument Structural Design, pp. 612-619	
	8	Zhang, X.X., "An Interference Filter Based External Cavity Laser For Dense Wavelength Division Multiplexing Applications" Corning OCA Corp. pgs 103-108	

Examiner Signature	<i>Jess</i>	Date Considered	10/5/02
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